## INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional) **4566**) FIS920010129US

Application Number unassigned 69/163,258

Applicant(s)

Lawrence Jacobowitz et al.

Filing Date

09/26/01 \_herewith

Group Art Unit \_unassigned

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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	CUMENT NUMBER DATE		NAME	CLASS	CLASS SUBCLASS		FILING DATE IF APPROPRIATE	
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